Examiner-Initiated Interview Summary	Application No.	Applicant(s)
	10/797,145	O'LENICK ET AL.
	Examiner	Art Unit
	Taylor Victor Oh	1625
All Participants:	Status of Application	on: <u>Allowed</u>
(1) <u>Taylor Victor Oh</u> .	(3)	
(2) <u>A.J.O'Lenick, Jr.</u> .	(4)	
Date of Interview: 18 August 2005	Time:	
Type of Interview: ☑ Telephonic ☐ Video Conference ☐ Personal (Copy given to: ☐ Applicant ☐ Applic	cant's representative)	
Exhibit Shown or Demonstrated: Yes No If Yes, provide a brief description:		
Part I.	·	
Rejection(s) discussed:		
Claims discussed:		
Prior art documents discussed:	•	
		•
Part II.		
SUBSTANCE OF INTERVIEW DESCRIBING THE GENE The examiner and applicants are agreed to delete the phrase "	RAL NATURE OF WHA' Surprisingly, because of the	T WAS DISCUSSED: " in the specification on page 2 ,line 4.
Part III.		
 It is not necessary for applicant to provide a separate directly resulted in the allowance of the application. The of the interview in the Notice of Allowability. It is not necessary for applicant to provide a separate did not result in resolution of all issues. A brief summar 	ne examiner will provide a record of the substance	of the interview, since the interview
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	•	
•		·
Tagh Nh		
(Examiner/SPE Signature) (Applicant	t/Applicant's Representat	tive Signature – if appropriate)

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Supplemental Examiner's Amendment and Reasons of Allowance

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The Status of Claims

Claims 1-2 are pending.

Claims 1-2 have been allowed.

1. An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

Authorization for this examiner's amendment was given in a telephone interview with an applicant of record, Mr. A.J. O'Lenick, Jr. on 8/18/05.

I. In the specification on page 2, line 4, the phrase "Surprisingly, because of the" has been deleted.

II. The application has been amended as follows:

In claim 1 on page 14:

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has been replaced with "HC-(CH₂)₇-".

In claim 2 on page 14:

The part of "-- HC--(CH₂)7- --" in the chemical formula of

has been replaced with "HC-(CH₂)₇-".

- III. The following is an examiner's statement of reasons for allowance:
 - The close reference for the current invention is Akeboshi et al (JP 04-202336).

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Akeboshi et al discloses the following compound below:

The instant invention, however, differs from the prior art in that the part of the claimed compound has a group of CH₂COO- attached to the nitrogen unlike the part of

the prior art compound has a group of

attached to the nitrogen.

Therefore, they are completely different from each other.

Therefore, the claimed invention would not have been obvious to the person with an ordinary skill in the art

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Any inquiry concerning the communication after allowance such as sending all post-allowance correspondence should be directed to "Box Issue Fee" or faxed directly to PUBS at 703-305-8755. This will expedite the process of these papers.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Juny WSh 9/27/55

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Supervisory Patent Examiner
Technology Center 1600